

Search Notes	Application/Control No.	Applicant(s)/Patent Under Reexamination
	10596294	WAKIYAMA, KOJI
Examiner	Art Unit	
Jason Heidemann	2624	

SEARCHED

Class	Subclass	Date	Examiner
348	61,77,78,207,99,207,1,156	10/14/2009	/JEH/
340	5,2,5,52,5,53,5,8,5,82,5,83,540,426,1	10/14/2009	/JEH/
351	200,205,206,209	10/14/2009	/JEH/
382	100,115,117,118	10/14/2009	/JEH/
396	155,14,18,	10/14/2009	/JEH/
713	182,185,186	10/14/2009	/JEH/

SEARCH NOTES

Search Notes	Date	Examiner
Searched Class and Subclass with Keywords (iris, focus, authentication, etc)	10/14/2009	/JEH/
Searched Google, ACM, and IEEE with keywords (iris focus, multiple focus ranges, etc)	10/14/2009	/JEH/
Author Search conducted on East	10/14/2009	/JEH/
Author Search Conducted on Google, ACM, and IEEE	10/14/2009	/JEH/

INTERFERENCE SEARCH

Class	Subclass	Date	Examiner

/Jason Heidemann/ Examiner Art Unit 2624	10/14/2009
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